

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Luetzen, *et al.* Docket No.: INF 2004 SP 00115 US  
Serial No.: 10/721,225 Conf. No.: 5694  
Art Unit: 1792 Examiner: George A. Goudreau  
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For: Method and Structures for Increasing the Structure Density and the  
Storage Capacitance in a Semiconductor Wafer

Commissioner for Patents  
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### STATEMENT OF COMMON OWNERSHIP

At the time the invention of Application Serial No. 10/721,225 was made, both U.S. Application Serial No. 10/721,225 and U.S. Patent No. 6,566,273 were owned by, or subject to an obligation of assignment, to a common assignee.

Respectfully submitted,

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Date

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